



501.37436CV2

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: S. NISHIHARA et al.

Application No.: 10/721,902

Filed: November 26, 2003

For: METHOD OF FABRICATING SEMICONDUCTOR  
INTEGRATED CIRCUIT DEVICE

Art Unit: 2812

Examiner: L. Gurley

**RESPONSE**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 16, 2004

Sir:

In response to the Office Action mailed May 14, 2004, Applicants respectfully submit the following remarks, and enclosed Terminal Disclaimer. As will be shown in the following, it is respectfully submitted that the enclosed Terminal Disclaimer overcomes the obviousness-type double patenting rejection set forth in Item 3 on page 2 of the Office Action mailed May 14, 2004, the sole rejection of claims in this Office Action mailed May 14, 2004, such that all of the presently pending claims should be allowed and the above-identified application passed to issue.

Thus, in Item 3 on page 2 of the Office Action mailed May 14, 2004, the Examiner has rejected all of the presently pending claims under the judicially created doctrine of obviousness-type double patenting, as being unpatentable over claims 1-13 of U.S. Patent No. 6,693,001. In Item 2 on page 2 of this Office Action mailed May 14, 2004, the Examiner indicates that this obviousness-type double patenting